



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hans Wilfried Peter Koops
Klaus Edinger

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Title: **PROCEDURE FOR ETCHING OF MATERIALS AT THE SURFACE
WITH FOCUSSED ELECTRON BEAM INDUCED CHEMICAL
REACTION AT SAID SURFACE**

10 Application Serial No. : 10/628,174

Filing Date: July 28, 2003

Assignee: NaWoTec GmbH

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Priority claimed: October 16, 2002, European Patent No. 02 023 217.9

AMENDMENT

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This amendment is in response to Office Action dated October 14, 2005. A
petition for a two month extension and fee is being submitted herewith. Reconsideration
of claims 1-3 and 19-41 is respectfully requested.

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Petition is hereby made for a two-month extension of the period to respond to the
outstanding Official Action. A check in the amount of \$450.00, as the Petition fee, is
enclosed herewith. If there are any additional charges, or any overpayment, in connection
with the filing of the amendment, the Commissioner is hereby authorized to charge any
such deficiency, or credit any such overpayment, to Deposit Account 23-3060.

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450.00 DP

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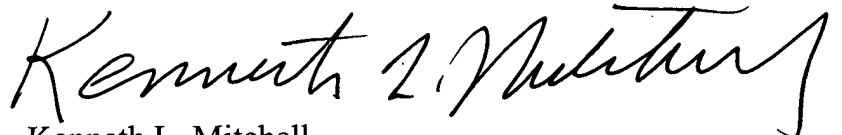
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02 FC:1806

180.00 DP

Respectfully submitted,

Woodling, Krost and Rust


Kenneth L. Mitchell

Ohio Bar Reg. No. 31587

Florida Bar Reg. No. 382531

Patent Attorney, Reg. No. 36,873

Registered Professional Engineer, Reg. No. 54455

Woodling, Krost and Rust

9213 Chillicothe Road

Kirtland, Ohio 44094

phone nos. 866-241-4150 (toll free), 440-256-4150;

fax nos. 866-241-4043 (toll free), 440-256-7453;

cell no. 440-487-2694

clevepat@aol.com

clevepat@sbcglobal.net